



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	
Takahiro IKEDA et al.	)
Application No.: 10/807,188	) Group Art Unit: 2624
Filed: March 24, 2004	) Examiner: Sheela C. Chawan
For: GRAPHIC CONTOUR EXTRACTING METHOD, PATTERN INSPECTING METHOD, PROGRAM AND PATTERN INSPECTING SYSTEM	) Confirmation No. 3749 ) ) )

## **Mail Stop Amendment**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

## **AMENDMENT**

In reply to the Office Action mailed January 9, 2007, the period for response having been extended to July 9, 2007, by the Petition for Extension of Time of three months and fee payment filed concurrently herewith, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment section of this paper.